

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/778,020	TSUCHIYA, HITOSHI	•
Examiner	Art Unit	
(Nancy) Thanh-Nhan P. Nguyen	2871	

SEARCHED							
Class	Subclass	Date	Examiner				
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
		-			

SEARCH NOTES (INCLUDING SEARCH STRATEGY)					
	DATE	EXMR			
UPDATE EAST search see printout. PLUS search see printout.	10/12/2005	TN ·			
349/113-114.ccls. (text search only) see printout.	10/12/2005	TN			